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# scanning electron microscopy



material- and damage investigation
3D microstructure and contour analysis
high resolution scanning electron spectroscopy
precise chemical and structural analysis
Focus Ion Beam micromachining

Insitu - micromechanical investigations

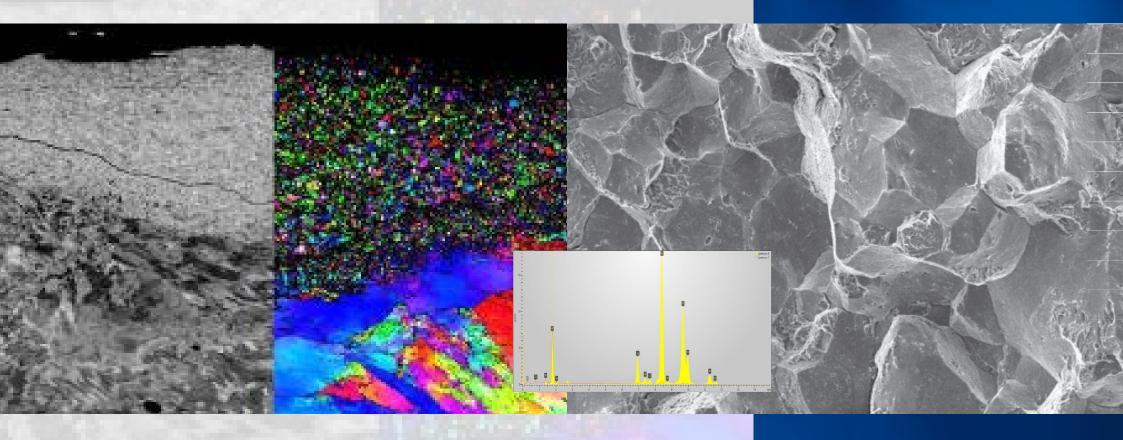
Insitu - temperatur transformation analytics

Ex-/Insitu - AFM-measurements



COMPETENCE & RELIABILITY

# material- and damage investigation



high-resolution examination of material sections, surfaces or fracture surfaces incl. local chemical and crystallographic analysis

contact

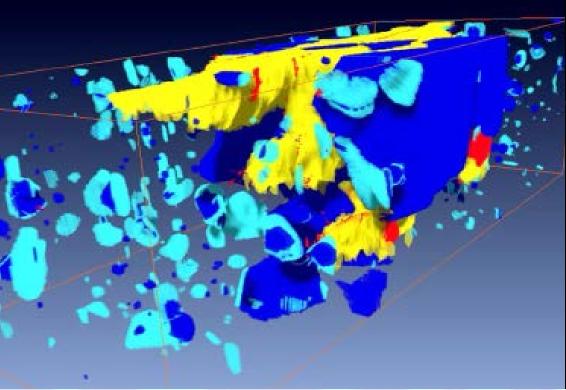
# DI Petri Prevedel P +43-3842-45922-23

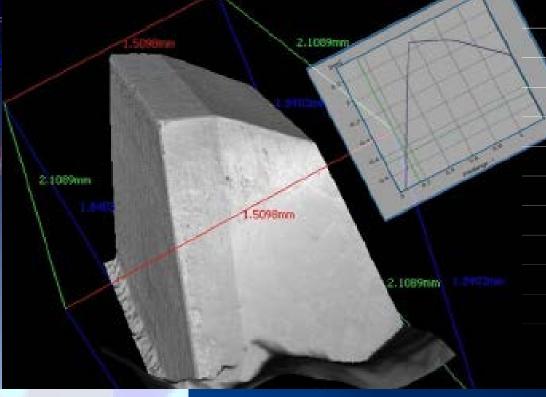


Dr. Angelika Spalek P+43-3842-45922-562

- surface analyses, fracture surface analyses, damage analyses
- analysis of large or difficult-to-clean components (up to 3kg), from microsections up to microelectronic components
- SEM analysis of non-conductive components without additional vapor deposition (e.g. ceramic components, metal/plastic composites)
- local chemical and crystallographic analyses

# 3D microstructure and contour analysis





high-resolution 3-dimensional examination and measurement of contours or structural components

#### contact

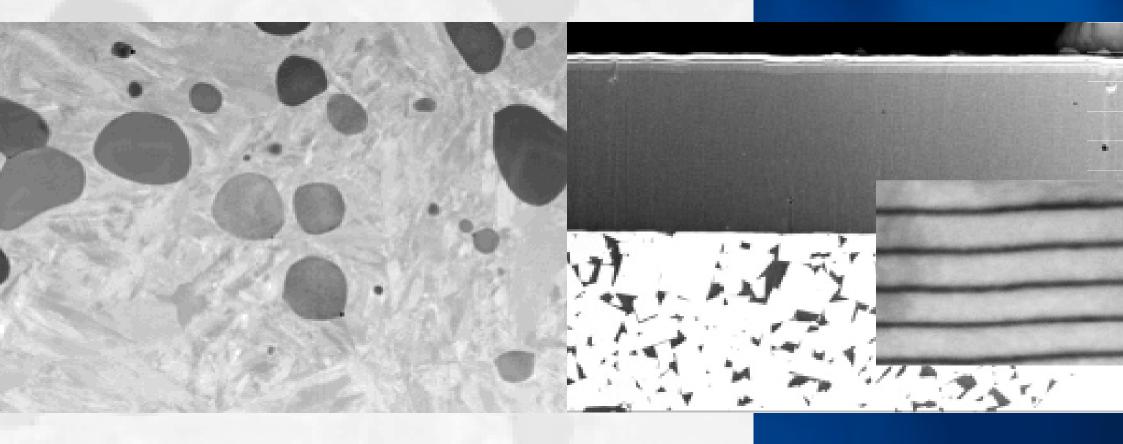
Bernhard Sartory P+43-3842-45922 - 98



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- 3D topography of contours, damage, etc. incl. measurement in the mm to sub-µm range
- 3D tomography of microstructural components by the Slive&View method incl. measurement of local chemistry and structure
- different electron constrasts, EBSD orientation measurement, local chemical composition over the measurable spectrum from lithium to uranium (EDX, WDX, XRF)

# high resolution scanning electron spectroscopy



high resolution microstructure characterization

#### contact





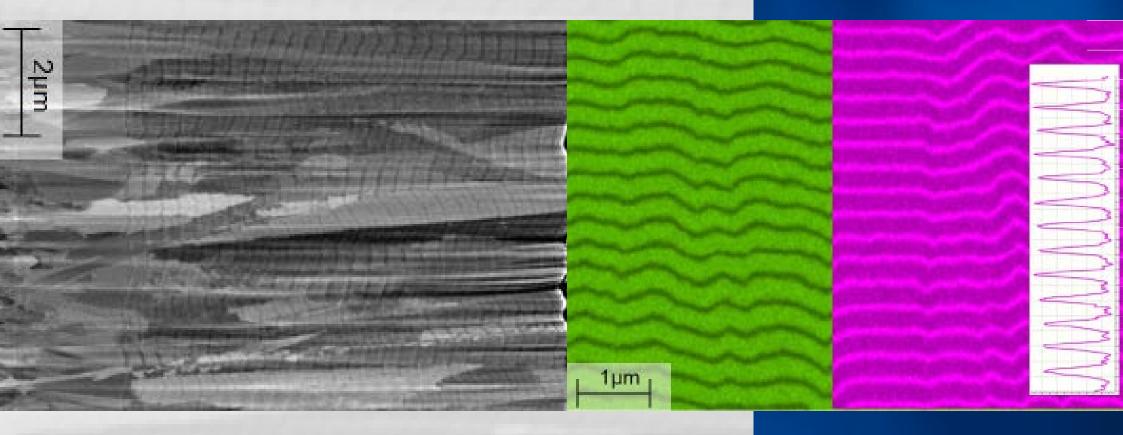
Dr. Kerstin Chladil P+43-3842-45922 - 22

### our focus / competences

- high resolution microstructure characterization with resolutions up to 1,000,000x
- different electron and ion constrasts, EBSD orientation measurement.
- measurement of the crystal structure by EBSD from the cm range down to 20-30nm small structures
- measurement of the local chemical composition over the measurable spectrum from lithium to uranium (EDX, WDX, XRF)

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# precise chemical and structural analysis



precise chemical and structural analysis of finest structural elements down to a few 10nm in size

#### contact

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- precise chemical analysis using EDX, WDX and XRF
- high energy resolution with detection limits of 50-100 ppm
- trace element analyses down to detection limits of 10ppm
- EBSD measurements of grains less than 10nm in size for identification of microstructure or crystal structure

# Focused Ion Beam micromachining



specimen preparation for micromechanical and microstructural investigations

contact





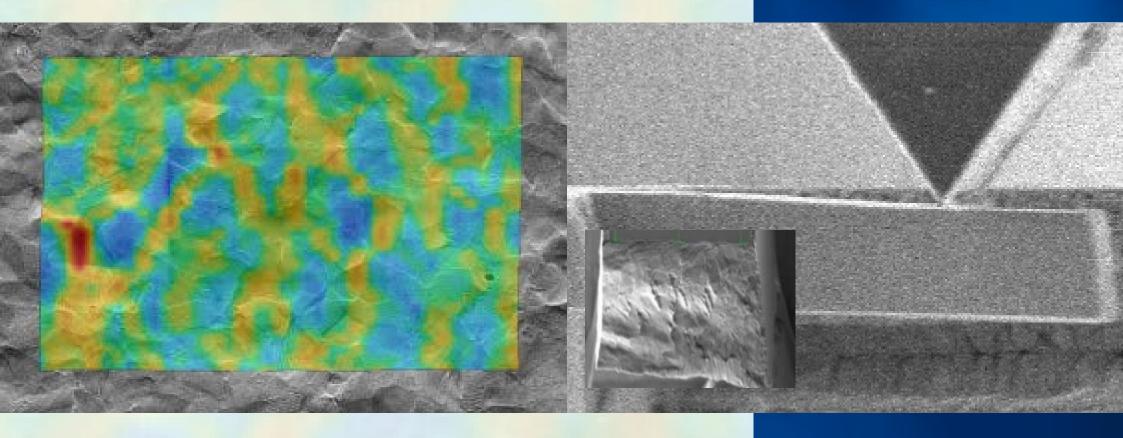
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#### our focus / competences

- target preparation of thin foils for subsequent electron microscopy and transmission electron microscopy examinations (\*)
- target preparation of atom probe tips for subsequent atom probe examinations
- preparation of specimens for micromechanical testing of materials (e.g. thin films or microstructural components)

\*advanced TEM, APFIM analyses are performed in cooperation with research partners of the MCL

# Insitu - micromechanical investigations



determination of micromechanical properties of microstructural components or layers

contact



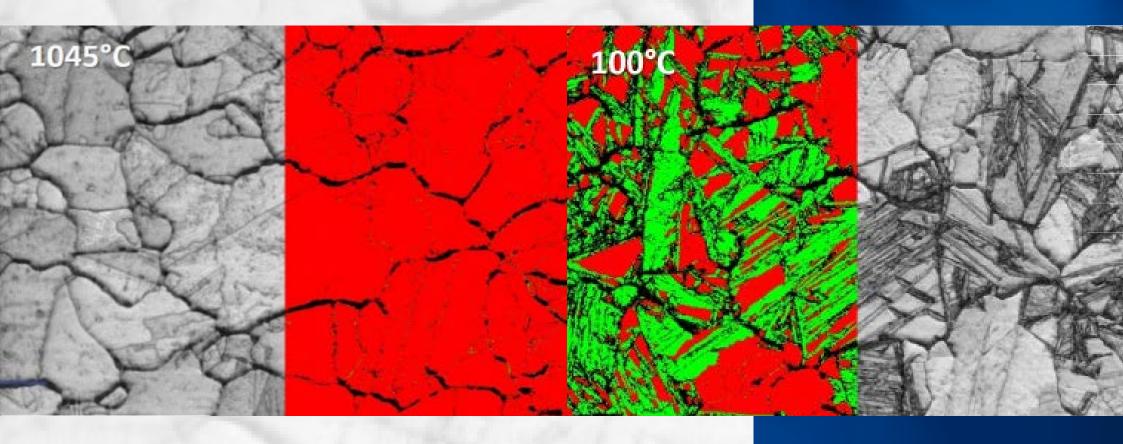
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### our focus / competences

- hardness testing of individual microstructural fractions
- Insitu tensile test to observe local strain changes
- Insitu hardness testing using nanoindentor, recording flow curves and determination of Young's modulus
- Insitu static and cyclic material testing using the nanoindentor, determination of fracture and fatigue properties
- testing of shear resistances at interfaces (e.g. interface of a coating)

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# Insitu - temperatur transformation analytics



High-resolution documentation of the transformation kinetics of individual phase fractions

#### contact

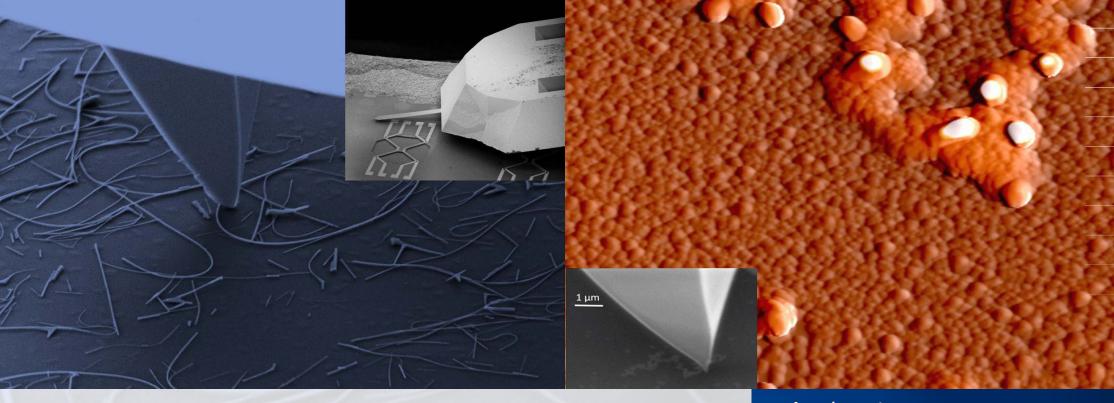


#### our focus / competences

- Insitu heating and cooling experiments in the scanning electron microscope
- temperature range -180°C to 1045°C
- heating rates:-180°C to 400°C max. 20°C/min
   250°C to 1045°C max. 250°/min
- temperature-dependent residual stress measurement on coatings
- analysis with various detectors (including EBSD)

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## **Ex-/Insitu-AFM measurements**



determination of local electrical, thermal and magnetic properties and surface topographies

#### contact



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- topography / roughness
- KPFM for the determination of local electrical properties of grains or microstructural components
- SThM for determination of thermal conductivity of grains or microstructure components
- EBIC for determination of local electrical properties and short circuits/interruptions
- MFM for determination of local magnetic properties (e.g.: retained austenite)
- STM for visualization of atoms or atomic lattice
- C-SPM for measuring electrical properties such as resistance or conductivity

## Service offer

- SEM characterization of surfaces, fracture surfaces, damage and microsections incl. local chemical composition
- material investigations up to 3D microstructures, topography and tomography using SEM-FIB technology
- target preparation of TEM thin films, atom probe tips for further high-resolution investigations
- preparation of microsamples for mechanical in-situ experiments with different geometries (e.g. cuboids, cylinders or micro tensile specimens and cantilever)
- investigation of TEM samples in transmission mode (STEM) incl. chemical and crystallographic analysis
- insertion of small crack-like defects (in the sub-µm to µm range) to study the behavior of short cracks
- local and depth-resolved residual stress measurements
- high temperature investigations in combination with EBSD
- determination of physical parameters in combination with modules and analytics
- SPM-SEM in combination of different modules
- one to several days on-site training in preparation & microstructure evaluation



# equipment

- scanning electron microscope with large sample chamber of Zeiss type EVO MA25<sup>®</sup> for the analysis of non-conductive and contaminated samples.
- dual-beam FE-SEM (Zeiss AURIGA®-CrossBeam®) incl. Focused Ion Beam System (FIB)
- high-resolution FE-SEM (Zeiss Gemini®-SEM 450) for imaging structures with a few nm and precise chemical analysis
- modular SEM (Zeiss CrossBeam®-SEM 340) with
  - tensile/compression/bending module
  - nanoindenter
  - heating/cryogenic module
  - AFM
- Acquisition techniques and analytics: SE, BSD, STEM, secondary ion, InLens and EBSD detector, EDX, WDX, ED-XRF, WD-XRF, EBSD, STEM, TKD (Transmission EBSD)
- ionslicer for sample preparation (flatmilling, cross sectioning)
- vapor deposition with different substances (graphite, platinum,...)
   for charge compensation and analysis of non-suffering samples



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